

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	§		
Ilya Karpov et al.	§	Art Unit:	Unassigned
	§		
Serial No.:	§		
Unassigned	§	Examiner:	Unassigned
	§		
Filed:	§		
April 12, 2004	§		
	§		
For: Fabricating Deeper and Shallower	§	Atty Docket:	ITL.0835D1US
Trenches in Semiconductor Structures	§		P14730D

Mail Stop **Patent Application**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Please amend the above-referenced application.